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Typed or printed name: EIA M. Lynch
Signature: EIA M. Lynch

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yu Wang et al.

: Group Art Unit: 3744

Application No. 10/766,140

: Examiner: W.C. Doerrler

Filed: January 27, 2004

: Response to Paper No. 20050401

For: VACUUM RETENTION METHOD
AND SUPERCONDUCTING
MACHINE WITH VACUUM
RETENTION

AMENDMENT UNDER 37 CFR 1.111

Assistant Commissioner for Patents
Alexandria, VA 22313-1450

S I R:

In response to the non-final Office Action dated April 22, 2005, Applicants respectfully request that the above-identified application be amended as follows.